



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **FUKASAWA, Shinji**

Group Art Unit: **2814**

Serial No.: **09/855,590**

Examiner: **T. N. QUACH**

Filed: **May 15, 2001**

P.T.O. Confirmation No.: 1417

**FOR: SEMICONDUCTOR DEVICE HAVING A MULTIPLE LAYER WIRING
STRUCTURE, WIRING METHOD, WIRING DEVICE, AND RECORDING
MEDIUM**

AMENDMENT UNDER 37 CFR §1.111

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

December 10, 2004

Sir:

In response to the Office Action dated **August 10, 2004**, extended to **December 10, 2004** by
a **one (1)** month Petition for Extension of Time, please amend the above-identified application as
follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of
this paper.

Remarks/Arguments begin on page 10 of this paper.